

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/660,821	YEH ET AL.	
Examiner	Art Unit	
Kin-Chan Chen	1765	

SEARCHED							
Class	Subclass	Date		Examiner			
438	270	5/31/2005		5/31/2005 K-C			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
EAST key words search, USPAT, USPGPUB, EPO,JPO,Derwent, IBM-TDB, inventor search	5/31/2005	k. 16			
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